

FORM PTO-1390 (Modified)
(REV 11-98)

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

ATTORNEY'S DOCKET NUMBER

TRANSMITTAL LETTER TO THE UNITED STATES
DESIGNATED/ELECTED OFFICE (DO/EO/US)
CONCERNING A FILING UNDER 35 U.S.C. 371

WEI0028

U.S. APPLICATION NO. (IF KNOWN, SEE 37 CFR

09/937074INTERNATIONAL APPLICATION NO
PCT/EP00/02505INTERNATIONAL FILING DATE
22 March 2000 (22/03/2000)PRIORITY DATE CLAIMED
23 March 1999 (23/03/1999)

TITLE OF INVENTION

METHOD OF FORMING GLASS-CERAMIC PARTS AND/OR GLASS PARTS

APPLICANT(S) FOR DO/EO/US

Ulrich Fotheringham et al.

Applicant herewith submits to the United States Designated/Elected Office (DO/EO/US) the following items and other information:

1. ☒ This is a **FIRST** submission of items concerning a filing under 35 U.S.C. 371.
2. ☐ This is a **SECOND** or **SUBSEQUENT** submission of items concerning a filing under 35 U.S.C. 371.
3. ☒ This is an express request to begin national examination procedures (35 U.S.C. 371(f)) at any time rather than delay examination until the expiration of the applicable time limit set in 35 U.S.C. 371(b) and PCT Articles 22 and 39(1).
4. ☒ A proper Demand for International Preliminary Examination was made by the 19th month from the earliest claimed priority date.
5. ☒ A copy of the International Application as filed (35 U.S.C. 371 (c) (2))
 - a. ☒ is transmitted herewith (required only if not transmitted by the International Bureau).
 - b. ☐ has been transmitted by the International Bureau.
 - c. ☐ is not required, as the application was filed in the United States Receiving Office (RO/US).
6. ☒ A translation of the International Application into English (35 U.S.C. 371(c)(2)).
7. ☒ A copy of the International Search Report (PCT/ISA/210).
8. ☐ Amendments to the claims of the International Application under PCT Article 19 (35 U.S.C. 371 (c)(3))
 - a. ☐ are transmitted herewith (required only if not transmitted by the International Bureau).
 - b. ☐ have been transmitted by the International Bureau.
 - c. ☐ have not been made; however, the time limit for making such amendments has NOT expired.
 - d. ☐ have not been made and will not be made.
9. ☐ A translation of the amendments to the claims under PCT Article 19 (35 U.S.C. 371(c)(3)).
10. ☒ An oath or declaration of the inventor(s) (35 U.S.C. 371 (c)(4)).
11. ☒ A copy of the International Preliminary Examination Report (PCT/IPEA/409).
12. ☒ A translation of the annexes to the International Preliminary Examination Report under PCT Article 36 (35 U.S.C. 371 (c)(5)).

Items 13 to 20 below concern document(s) or information included:

13. ☒ An Information Disclosure Statement under 37 CFR 1.97 and 1.98.
14. ☐ An assignment document for recording. A separate cover sheet in compliance with 37 CFR 3.28 and 3.31 is included.
15. ☒ A **FIRST** preliminary amendment.
16. ☐ A **SECOND** or **SUBSEQUENT** preliminary amendment.
17. ☐ A substitute specification.
18. ☐ A change of power of attorney and/or address letter.
19. ☒ Certificate of Mailing by Express Mail
20. ☒ Other items or information:

Check No. **100819**

U.S. APPLICATION NO. (IF KNOWN, SEE 37 CFR 1.53) 09/937074		INTERNATIONAL APPLICATION NO. PCT/EP00/02505		ATTORNEY'S DOCKET NUMBER WEI0028	
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21. The following fees are submitted:				CALCULATIONS PTO USE ONLY	
BASIC NATIONAL FEE (37 CFR 1.492 (a) (1) - (5)) : <input type="checkbox"/> Neither international preliminary examination fee (37 CFR 1.482) nor international search fee (37 CFR 1.445(a)(2)) paid to USPTO and International Search Report not prepared by the EPO or JPO \$1,000.00 <input checked="" type="checkbox"/> International preliminary examination fee (37 CFR 1.482) not paid to USPTO but International Search Report prepared by the EPO or JPO \$860.00 <input type="checkbox"/> International preliminary examination fee (37 CFR 1.482) not paid to USPTO but international search fee (37 CFR 1.445(a)(2)) paid to USPTO \$710.00 <input type="checkbox"/> International preliminary examination fee paid to USPTO (37 CFR 1.482) but all claims did not satisfy provisions of PCT Article 33(1)-(4) \$690.00 <input type="checkbox"/> International preliminary examination fee paid to USPTO (37 CFR 1.482) and all claims satisfied provisions of PCT Article 33(1)-(4) \$100.00					
ENTER APPROPRIATE BASIC FEE AMOUNT =				\$860.00	
Surcharge of \$130.00 for furnishing the oath or declaration later than <input type="checkbox"/> 20 <input type="checkbox"/> 30 months from the earliest claimed priority date (37 CFR 1.492 (e)).				\$0.00	
CLAIMS	NUMBER FILED	NUMBER EXTRA	RATE		
Total claims	24 - 20 =	4	x \$18.00	\$72.00	
Independent claims	1 - 3 =	0	x \$80.00	\$0.00	
Multiple Dependent Claims (check if applicable). <input type="checkbox"/>				\$0.00	
TOTAL OF ABOVE CALCULATIONS =				\$932.00	
Reduction of 1/2 for filing by small entity, if applicable. Verified Small Entity Statement must also be filed (Note 37 CFR 1.9, 1.27, 1.28) (check if applicable). <input type="checkbox"/>				\$0.00	
SUBTOTAL =				\$932.00	
Processing fee of \$130.00 for furnishing the English translation later than <input type="checkbox"/> 20 <input type="checkbox"/> 30 months from the earliest claimed priority date (37 CFR 1.492 (f)).				\$0.00	
TOTAL NATIONAL FEE =				\$932.00	
Fee for recording the enclosed assignment (37 CFR 1.21(h)). The assignment must be accompanied by an appropriate cover sheet (37 CFR 3.28, 3.31) (check if applicable). <input type="checkbox"/>				\$0.00	
TOTAL FEES ENCLOSED =				\$932.00	
				Amount to be:	\$
				refunded	
				charged	\$

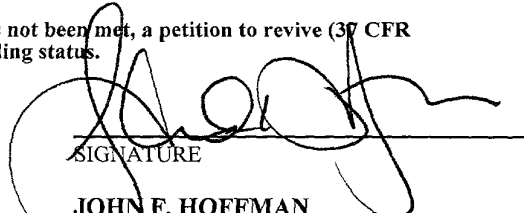
☒ A check in the amount of **\$932.00** to cover the above fees is enclosed.
☐ Please charge my Deposit Account No. _____ in the amount of _____ to cover the above fees.
 A duplicate copy of this sheet is enclosed.
☒ The Commissioner is hereby authorized to charge any fees which may be required, or credit any overpayment to Deposit Account No. **02-0385** A duplicate copy of this sheet is enclosed.

NOTE: Where an appropriate time limit under 37 CFR 1.494 or 1.495 has not been met, a petition to revive (37 CFR 1.137(a) or (b)) must be filed and granted to restore the application to pending status.

SEND ALL CORRESPONDENCE TO:

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 SIGNATURE
JOHN F. HOFFMAN
 NAME
26,280
 REGISTRATION NUMBER
September 20, 2001
 DATE

CERTIFICATE OF MAILING BY "EXPRESS MAIL" (37 CFR 1.10)

Applicant(s) **Ulrich Fotheringham et al.**

Docket No.

WEI0028

Serial No.

Filing Date

Examiner

Group Art Unit

Invention:

METHOD OF FORMING GLASS-CERAMIC PARTS AND/OR GLASS PARTS

I hereby certify that the following correspondence:

New U.S. National Stage Patent Application

(Identify type of correspondence)

is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under

37 CFR 1.10 in an envelope addressed to: The Assistant Commissioner for Patents, Washington, D.C. 20231 on

September 20, 2001

(Date)

Patrice Michele Potter

(Typed or Printed Name of Person Mailing Correspondence)

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of)
Ulrich Fotheringham et al.) Group:
Serial No.)
Filed:) Examiner:
Title: METHOD OF FORMING GLASS-)
CERAMIC PARTS AND/OR GLASS)
PARTS)

**PRELIMINARY AMENDMENT DELETING
MULTIPLE DEPENDENT CLAIMS**

Assistant Commissioner of Patents
Washington, DC 20231

Sir:


Prior to calculating the filing fee, please enter the following amendments to the application.

IN THE CLAIMS

In claim 4, line 1, delete "any of the claims 1 to 3" and substitute therefor --claim 1--.
In claim 5, line 1, delete "any of the claims 1 to 4" and substitute therefor --claim 1--.
In claim 6, line 1, delete "any of the claims 1 to 5" and substitute therefor --claim 1--.
In claim 7, line 1, delete "any of the claims 1 to 6" and substitute therefor --claim 1--.
In claim 8, line 1, delete "any of the claims 1 to 7" and substitute therefor --claim 1--.
In claim 9, line 1, delete "any of the claims 1 to 8" and substitute therefor --claim 1--.
In claim 10, line 1, delete "any of the claims 1 to 9" and substitute therefor --claim 1--.
In claim 11, line 1, delete "any of the claims 1 to 10" and substitute therefor --claim 1--.
In claim 12, line 1, delete "any of the claims 1 to 11" and substitute therefor --claim 1--.
In claim 14, line 1, delete "any of the claims 1 to 13" and substitute therefor --claim 1--.
In claim 16, line 1, delete "any of the claims 1 to 15" and substitute therefor --claim 1--.
In claim 18, line 1, delete "any of the claims 1 to 17" and substitute therefor --claim 1--.
In claim 21, line 1, delete "any of the claims 18 to 20" and substitute therefor
--claim 18--.
In claim 22, line 1, delete "any of the claims 18 to 21" and substitute therefor
--claim 18--.
In claim 23, line 1, delete "any of the claims 18 to 22" and substitute therefor
--claim 18--.

[illegible]

Respectfully submitted,



John F. Hoffman
Registration No.26,280

Attorney for Applicant

~~Attorney for Applicant~~

BAKER & DANIELS
111 East Wayne Street, Suite 800
Fort Wayne, IN 46802

Date: September 20, 2001

Re: Patent No. WO 00/56674- PCT/EP00/02505

AFFIDAVIT

I hereby certify that I have made the foregoing translation from German into English. I further certify that I am a competent translator well acquainted with both languages, and that, to the best of my knowledge and belief, the foregoing translation is a true and complete rendering into English of the original document.

A handwritten signature in cursive script, appearing to read 'Ursula Kewer', written in dark ink on a light background.

Ursula Kewer

Date: August 22, 2001

6/prts

WO 00/56674

PCT/EP00/02505

METHOD FOR FORMING GLASS-CERAMIC PARTS AND/OR GLASS PARTS

(0001) The invention relates to a method for producing glass-ceramic parts and/or glass parts by means of deformation of a glass-ceramic blank and/or glass blank and to a device for carrying out said method.

(0002) Forming glass-ceramics, especially 3D forming using a first method based on the state of the art starts with a vitreous fabricated material because once the glass has been ceramized the only way of deforming it again is generally via the detour of melting.

(0003) In order to deform the basic glass of glass-ceramics with the forming methods usually used for glass, for example gravity lowering or vacuum lowering, it is typically heated to temperatures around 1000°C where crystal growth will take place if nuclei were previously formed. When the basic glass is heated to the target temperature of 1000°C, for example, where crystal growth can occur, the nucleation range, where minute crystallization nuclei are separated and which is between 700°C and 800°C, inevitably has to be passed.

(0004) In order to prevent nucleation that may be inhomogeneous in the critical nucleation range and to prevent that the properties of the glass-ceramic produced by the subsequent ceramizing process are adversely affected or that the prenucleation will cause crystallization in the subsequent forming process, thereby making the process impossible, the nucleation range has to be passed as quickly as possible.

(0005) Forming glass originates with a glass blank and the usual deformation methods used for glass, such as gravity lowering or vacuum lowering, where the glass blank is typically heated to temperatures above the softening point of 1000°C, for example.

(0006) Heating the glass-ceramic blank or the glass blank quickly can be achieved, for example, in that high-capacity surface heaters, such as gas burners are used.

(0007) Generally, the term surface heaters refers to heaters where at least 50% of the total heat flow from the heat source is supplied to the surface or the near-surface layers of the object to be heated.

(0008) A special type of surface heating is the above described heating method using a gas flame where the flame temperatures are typically around 1000°C. Heating by means of a gas burner mostly takes place in that the heat energy of the hot gas is transferred across the surface of the glass-ceramic blank or glass

blank. This may result in a temperature gradient that can adversely affect the forming because of viscosity gradients, for example. This particularly applies to glass thicknesses of ≥ 5 mm.

(0009) In order to through-heat the glass or glass-ceramic blank quickly by means of heat conduction the gas burner requires a high capacity output. Such heating is limited to small areas because gas burners are not capable of providing the required full-surface power density.

(0010) Therefore, heating with gas burners is especially not suitable for producing complex 3D glass-ceramics and it is limited to simple geometries.

(0011) Other disadvantages of heating with gas burners are the following, for example:

- relatively uncontrolled flame operation,
- interfering gasses are carried in,

which can adversely affect the quality of the material.

(0012) Another option for producing three-dimensionally deformed glass-ceramics is placing them on the appropriate mold during the ceramizing process. However, the required low viscosities will not be obtained in this case, and as a result complex geometries can be formed only with very high bending radii.

(0013) PCT/FR96/00927 described reprocessing preliminary stages of glass-ceramics where the rolled ribbon of glass coming from high temperatures is formed directly at the melting tank when the required temperature is obtained, even before the critical nucleation range of glass-ceramics is reached.

(0014) The disadvantage of the method disclosed in PCT/FR96/00927 is the exceptionally high effort because the continuous process of forming glass has to be altered directly. Also, a subsequent forming process, separate from the tank operation, of intermediately stored glass-ceramic blanks for example, by means of reheating after they have cooled is not possible.

(0015) Another option for producing three-dimensionally formed glass is forming it in that it is positioned on the appropriate mold already during or after the melting process instead of using a glass blank.

(0016) In this case, the glass can be formed directly at the melting tank from a rolled ribbon of glass, for example.

(0017) The disadvantage of such a method is that the glass forming process is coupled to the tank operation.

(0018) It is the object of the invention to provide a method and a device for producing glass-ceramic parts and/or glass parts by means of deformation of a glass-

ceramic blank and/or glass blank which overcome the above described disadvantages. The method should especially provide the following possibilities:

- a procedure which is independent of the tank operation, for example a secondary procedure,
- complex 3D deformations even with very small bending radii,
- largely preventing undesired preceramization,
- largely preventing undesired temperature gradients.

(0019) The problem is solved by means of the invention in that the forming process of the method of the preamble is carried out using infrared radiation, preferably short-wave infrared radiation of $< 2.7 \mu\text{m}$ wavelength or NIR radiation.

(0020) According to a first embodiment of the invention the forming will take place while a glass blank is being softened.

According to a further embodiment of the invention the forming process takes place in that a glass-ceramic blank is reprocessed before it is ceramized. This offers the advantage that the glass can be deformed offline at any time.

(0021) An alternative would be forming the glass-ceramic blank together with its ceramization.

(0022) It is especially advantageous if the deformed glass-ceramic blank and/or glass blank is a glass plate.

(0023) All standard forming methods used for processing glass are conceivable as a forming method, for example forming by means of gravity lowering which may be supported by vacuum. In this case, it is called vacuum lowering. Alternatively, it can be lowered into the mold by means of a molding plug or by means of blowing in air.

(0024) In addition to the forming process by means of lowering into a mold, a directional infrared radiation of the glass or glass-ceramic blank to be formed can take place alternatively or in combination with the lowering process, which allows heating and thus forming specific zones.

(0025) In support of or as an alternative to directional infrared radiation certain areas of the blank can specifically be heated or remain cold by providing appropriately configured shields.

(0026) It is especially advantageous to carry out the complete forming process in an infrared radiation hollow and to apply the heat by means of infrared radiators as radiation sources.

(0027) According to an embodiment of the invention the glass-ceramic blank and/or glass blank is heated in part directly by means of infrared radiation from the

infrared radiators and in part indirectly by the infrared radiation which is reflected or back scattered by the walls, the ceiling and/or the floor of the infrared radiation hollow.

(0028) It is especially advantageous if the portion of the indirect radiation, i.e. the back scattered or reflected radiation acting on the glass or glass-ceramic blank to be heated, is more than 50%, preferably more than 60%, preferably more than 70%, especially preferably more than 80%, especially preferably more than 90%, in particular more than 98% of the total radiation output.

(0029) Preheating can be used so as to homogenize the temperature, for example in a conventional oven. Reheating a formed glass or a formed glass-ceramic is also conceivable.

(0030) In addition to the method, the invention also provides a device for carrying out said method which is characterized especially in that it comprises an infrared radiation hollow having walls, a ceiling and/or a floor reflecting the infrared radiation, where a multiplicity of infrared radiators is disposed in the infrared radiation hollow.

(0031) Infrared radiation hollows are described, for example, in US-A-4789771 and EP-A-O 133 847 whose disclosure content has been fully incorporated in this application. Preferably, the portion of the infrared radiation which is reflected and/or scattered by the wall surfaces, the floor and/or the ceiling is more than 50% of the radiation impinging on said surfaces.

(0032) It is particularly advantageous if the portion of the infrared radiation reflected and/or scattered by the wall surfaces, the floor and/or the ceiling is more than 90%, especially more than 98%.

(0033) A particular advantage of using an infrared radiation hollow is that when highly reflecting and/or back scattering wall, floor and/or ceiling materials are used, it is a high quality resonator subject only to minor losses and thus it ensures a high energy utilization.

(0034) Using wall, ceiling and/or floor materials that back scatter diffusely achieves an especially uniform irradiation of all volume elements of the hollow at all angles. This prevents potential shading effects in the case of complex formed glass-ceramic parts and/or glass parts.

(0035) Ground Quarzal plates can be used, for example, for back scattering, i.e. reflecting wall material, having a thickness of 30 mm, for example.

(0036) Other materials that back scatter the infrared radiation can also be used for wall, ceiling and/or floor materials or coatings for the infrared radiation hollow, for example one or more of the following materials:

Al₂O₃; BaF₂; BaTiO₃; CaF₂; CaTiO₃;
MgO 3,5 Al₂O₃; MgO, SrF₂; SiO₂;
SrTiO₃; TiO₂, Spinell, cordierite
cordierite sintered glass ceramic

(0037) In a preferred embodiment of the invention the infrared radiators have a color temperature of more than 1500 K, especially preferably more than 2000 K, most preferably more than 2400 K, in particular more than 2700 K, particularly preferably more than 3000 K.

(0038) In order to prevent the infrared radiators from overheating they are preferably cooled, especially air-cooled or water-cooled.

(0039) In order to specifically heat the glass or the glass-ceramic, for example by means of directional radiators, the infrared radiators can be turned off individually, in particular, their electrical output can be controlled.

(0040) The invention is described below by means of the figures and the exemplary embodiments, as follows:

(0041) Fig. 1 the Planckian locus of a potential infrared radiator having a temperature of 2400 K.

(0042) Fig. 2A the basic structure of a heating device according to the invention including a radiation hollow.

(0043) Fig. 2B the reflectance curve over the wavelength of Al₂O₃ Sintox AL made by Morgan Matroc, Troisdorf, with a diffuse reflectance of > 95%, and of > 98% over a wide spectral region, in the infrared wavelength range.

(0044) Fig. 3A the heating curve of a glass-ceramic blank to be formed in a heating device comprising an infrared radiation hollow.

(0045) Fig. 3B the heating curve of a glass blank to be formed in a heating device comprising an infrared radiation hollow.

(0046) Figs. 4A+B deformation of a glass-ceramic blank and/or glass blank by gravity lowering.

(0047) Figs. 5A+B deformation of a glass-ceramic blank and/or glass blank by vacuum lowering.

(0048) Fig. 6A+B deformation of a glass-ceramic blank and/or glass blank by lowering, supported by a compression molding tool.

(0049) Fig. 7A+B deformation of a glass-ceramic blank and/or glass blank by lowering, supported by overpressure.

(0050) Fig. 8 deformation of a glass-ceramic blank and/or glass blank by means of directional infrared radiators.

(0051) Fig. 9 deformation of a glass-ceramic blank and/or glass blank in an infrared radiation hollow including a shield.

(0052) Fig. 1 illustrates the intensity distribution of an infrared radiation source such as can be used for heating a glass or glass-ceramic blank for complex forming in accordance with the invention. The infrared radiators used can be linear halogen infrared quartz tube radiators with a nominal capacity of 2000 W at a voltage of 230 V, preferably having a color temperature of 2400 K. According to the Wien displacement law the radiation maximum of said infrared radiators is at a wavelength of 1210 nm.

(0053) According to the forming method of the invention the heating device and the products to be baked or the glass or glass-ceramic blank to be formed are located in an infrared radiation hollow equipped with infrared radiators. This requires the quartz glass radiators to be adequately temperature-resistant or appropriately cooled. The quartz glass tube can be used up to approx. 1100°C. It is preferable to configure the quartz glass tubes considerably longer than the heating spiral and to guide them out of the hot area so that the connections are in the cold area so as not to overheat the electrical connections. The quartz glass tubes can be made with or without coating.

(0054) Fig. 2A shows a first embodiment of a heating device for a forming method of the invention including an infrared radiation hollow.

(0055) The heating device shown in Fig. 2A comprises a multiplicity of infrared radiators 1, which are disposed below a reflector 3 of highly reflecting or highly back scattering material. With the reflector 3 the output supplied by the infrared radiator into other directions can be guided to the glass or glass-ceramic blank. The infrared radiation supplied by the infrared radiators partially penetrates the glass-ceramic blank 5 or glass blank 5, which is semi-transparent in this wavelength range, and meets a carrier plate 7 of highly reflecting or highly scattering material. Quarzal is especially suitable for this. It reflects approx. 90% of the impinging radiation in the infrared range. Alternatively, Al_2O_3 could be used which has a degree of reflection of approx. 98%. The glass-ceramic blank 5 or glass blank 5 is positioned on the carrier plate 7 by means of Quarzal or Al_2O_3 strips 9, for example. The temperature on the underside can be measured by means of a pyrometer through a hole 11 in the carrier plate.

(0056) With an appropriate configuration using a reflecting or diffusely back scattering material or Quarzal or Al_2O_3 , the walls 10, in combination with the reflector 3 as a ceiling and the carrier plate 7 as a floor, can form an infrared radiation hollow of high quality.

(0057) Fig. 3A shows the heating curve of a glass-ceramic blank to be formed according to a method of the invention where the glass-ceramic blank to be formed measures approx. 200 mm and has a thickness of 4 mm.

(0058) Fig. 3B shows the heating curve of a glass blank to be formed according to a method of the invention where the glass sample to be formed measures approx. 200 mm and has a thickness of 4 mm.

(0059) The heating method or the heat treatment, respectively, is described below:

(0060) The glass-ceramic blanks to be formed and subsequently ceramized, if required, or the glass blanks to be formed were initially heated in an infrared radiation hollow walled in with Quarzal as per Fig. 2A whose ceiling was formed by an aluminum reflector with infrared radiators disposed underneath. The samples were suitably positioned on Quarzal.

(0061) In the infrared radiation hollow the glass or glass-ceramic blanks were directly irradiated by multiple halogen infrared radiators which were disposed at a distance of between 10 mm and 150 mm above the glass or glass-ceramic blanks to be formed.

(0062) The respective glass-ceramic blank or glass blank was then heated up by means of controlling the infrared radiator via a thyristor regulator based on absorption, reflection and scattering processes, as described below in detail:

(0063) Because the absorption length of the applied short-wave infrared radiation in the glass is very much larger than the dimensions of the objects to be heated most of the impinging radiation is able to pass through the sample. On the other hand, because the absorbed energy per volume is virtually identical at all points of the glass homogeneous heat is achieved over the entire volume. In the test as per Figs. 3A and 3B for the glass-ceramic or glass sample to be formed the infrared radiators and the glass or glass-ceramic blank to be heated are located in a radiation hollow whose walls, floor and/or ceiling consist of a material whose surface is highly reflective, where at least a portion of the wall, floor and/or ceiling surface back scatters the radiation predominantly diffusely. This causes the predominant portion of the radiation, which is initially able to pass through the glass or glass-ceramic blank, to reenter the object to be heated after reflecting or scattering on the wall, floor and/or ceiling, and it is partially absorbed again. The path of the radiation which is also able to pass through the glass or glass-ceramic blank in the second passage continues analogous. This method not only achieves a deep homogeneous heat, the utilization of the applied energy is considerably better than with a single passage through the glass or glass-ceramic blank.

(0064) Figs. 4A and 4B illustrate the structure of the forming process for a glass or glass-ceramic blank 5 in an infrared radiation hollow with infrared heating radiators 1 by means of gravity lowering.

(0065) The infrared radiators 1 are disposed in the radiation hollow above the glass-ceramic blank 5 or glass blank 5 to be formed. The reflectors 3 are positioned above the infrared radiators 1.

(0066) The infrared radiators 1 heat the glass-ceramic blank 5 or glass blank 5 from the top. The mold 50 into which the blank 5 is lowered is coated with infrared reflecting material as are the walls 10 of the infrared radiation hollow. More than 50%, preferably 90 or 95%, especially preferably 98% of the infrared radiation meeting the walls 10 or the mold 50 are reflected. During the subsequent passage the reflected radiation again heats up the glass-ceramic blank or glass blank.

(0067) If a certain temperature in the glass-ceramic blank or glass blank is exceeded the heated glass-ceramic blank or glass blank will be lowered into the mold 50 because of its gravity as illustrated in Fig. 4B.

(0068) For glass-ceramic blanks the forming process can be carried out both before ceramization or together with the ceramizing process.

(0069) After the forming process has been completed the formed glass or glass-ceramic part is removed from the mold after the heat from the infrared radiators has been turned off.

(0070) Reheating in an oven is conceivable.

(0071) The forming process can be supported by providing a vacuum as illustrated in Figs. 5A and 5B.

(0072) For this purpose, a vacuum connection 52 will be provided in the mold below the glass-ceramic blank 5 or the glass blank 5 to be formed.

(0073) The gravity lowering process after heating up by means of the infrared radiators is supported by supplying a vacuum.

(0074) Alternatively, as shown in Figs. 6A and 6B, the deformation process can be supported by means of a molding plug 54. In this case, after the plate is heated the infrared radiators, which are positioned above the plate to be heated, are preferably shifted and subsequently the heated plate 5 is lowered into the mold by means of the molding tool or the molding plug 52.

(0075) As an alternative to shifting the infrared radiators the mold with the heated plate could also be shifted.

(0076) Instead of lowering by means of a molding plug 54 it is possible to place the heated plate into the mold by blowing in an overpressure by means of a blow tool 56, as shown in Figs. 7A and 7B.

(0077) Fig. 8 shows the selective heating of a glass-ceramic blank or glass blank by means of directional infrared radiators 100.

(0078) With such directional heating the deformation processes can be employed in certain specific areas of the glass-ceramic blank or glass blank to be formed. By individually controlling the directional infrared radiators 100 it is possible to produce temperature profiles distributed over an area in the glass-ceramic blank or glass blank to be formed so as to provide the glass-ceramic or the glass with any desired, predetermined form.

(0079) Shields 102 can be provided instead of directional and individually controlled infrared radiators which shields are placed between the infrared radiators 1 and the top side of the plate 5 to be heated.

(0080) Such an embodiment of the invention is shown in Fig. 9.

(0081) Using the method of the invention the material reaches temperatures in the range between 1150°C and 1200°C and above, and it is also possible to provide that the temperature inhomogeneity in the work piece will not exceed ± 10 K before the forming process.

(0082) When the formed glass-ceramic part or glass part is removed the temperature of the formed glass-ceramic or the formed glass is preferably less than 250°C, the cooling rate of the glass-ceramic or the glass when the radiator is turned off is preferably above 150°C per minute.

(0083) Heating up a glass-ceramic or glass blank by means of the infrared radiation method preferably takes less than 60 seconds, and cooling preferably takes less than 180 seconds. The cooling can take place both outside or inside the unit, achieving cycles of 60 seconds for cooling outside the unit and of less than 5 min. when cooled inside the unit.

(0084) Fluted components, for example, can be produced by means of the method of the invention, having a circular arc cross-section of r less than 150 mm, the component having a width of less than 200 mm and fluted components of glass-ceramic or glass can be formed, for example, having a rectangular or trapezoid cross-section.

(0085) Complex three-dimensional type deformations are also feasible.

ART 34 AND

Patent Claims

1. Method for producing glass-ceramic parts and/or glass parts by means of deformation of a glass-ceramic and/or glass blank, characterized in that forming is carried out using infrared radiation, where the infrared radiation is a short-wave infrared radiation from an infrared radiation source with a color temperature of more than 1500 K, especially preferably more than 2000 K and a portion of the infrared radiation acts directly and another portion acts indirectly on the glass-ceramic blank and/or glass blank where the portion of the radiation acting indirectly on the glass-ceramic blank and/or glass blank is more than 50% of the total radiation output.
2. Method as per claim 1, characterized in that forming is carried out in that a glass-ceramic blank is reprocessed before it is ceramized.
3. Method as per claim 1, characterized in that forming is carried out together with the ceramization of a glass-ceramic blank.
4. Method as per any of the claims 1 to 3, characterized in that the glass-ceramic blank and/or the glass blank is a glass plate.
5. Method as per any of the claims 1 to 4, characterized in that forming is carried out while a glass blank is being softened.

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6. Method as per any of the claims 1 to 5, characterized in that forming comprises gravity lowering.
7. Method as per any of the claims 1 to 6, characterized in that forming comprises vacuum lowering.
8. Method as per any of the claims 1 to 7, characterized in that forming comprises lowering by means of a molding plug.
9. Method as per any of the claims 1 to 8, characterized in that forming comprises lowering by blowing.
10. Method as per any of the claims 1 to 9, characterized in that forming comprises a directional infrared irradiation of the glass-ceramic blank and/or glass blank to be formed.
11. Method as per any of the claims 1 to 10, characterized in that forming comprises the use of shields disposed between the infrared radiators and the glass or glass-ceramic blank.
12. Method as per any of the claims 1 to 11, characterized in that forming is carried out in an infrared radiation hollow.

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13. Method as per claim 12, characterized in that radiation heating is carried out by means of infrared radiators disposed in the radiation hollow.
14. Method as per any of the claims 1 to 13, characterized in that the glass-ceramic blank and/or glass blank is preheated.
15. Method as per claim 14, characterized in that the glass-ceramic blank and/or glass blank is preheated in a conventional oven.
16. Method as per any of the claims 1 to 15, characterized in that the glass-ceramic and/or the glass is reheated after forming.
17. Method as per claim 16, characterized in that the glass-ceramic and/or the glass is reheated in a conventional oven.
18. Device for carrying out the method as per any of the claims 1 to 17, characterized in that the device comprises:
 - 18.1 an infrared radiation hollow with walls and/or ceiling and/or floor reflecting or back scattering the infrared radiation,
 - 18.2 one or more infrared radiators, radiating infrared radiation with a color temperature of more than 1500 K, especially preferably more than 2000 K.
19. Device as per claim 18, characterized in that the reflectivity or the ability to back scatter of the walls and/or ceiling and/or floor is more than 50% of the impinging radiation.

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20. Device as per claim 18, characterized in that the reflectivity or the ability to back scatter of the walls and/or ceiling and/or floor is more than 90% or 95%, especially more than 98% of the impinging radiation.
21. Device as per any of the claims 18 to 20, characterized in that the material of the wall and/or the ceiling and/or the floor back scatters diffusely.
22. Device as per any of the claims 18 to 21, characterized in that the reflecting or back scattering walls and/or ceiling and/or floor comprise one or more of the following materials:
- Al_2O_3 ; BaF_2 ; BaTiO_3 ; CaF_2 ; CaTiO_3 ;
 MgO 3,5 Al_2O_3 ; MgO , SrF_2 ; SiO_2 ;
 SrTiO_3 ; TiO_2 , Spinell, cordierite
cordierite sintered glass ceramic
23. Device as per any of the claims 18 to 22, characterized in that the infrared radiators are cooled, especially air-cooled or water-cooled.
24. Device as per any of the claims 18 to 23, characterized in that the infrared radiators are individually controllable and that their electrical output is controllable.

1/6

Fig.1

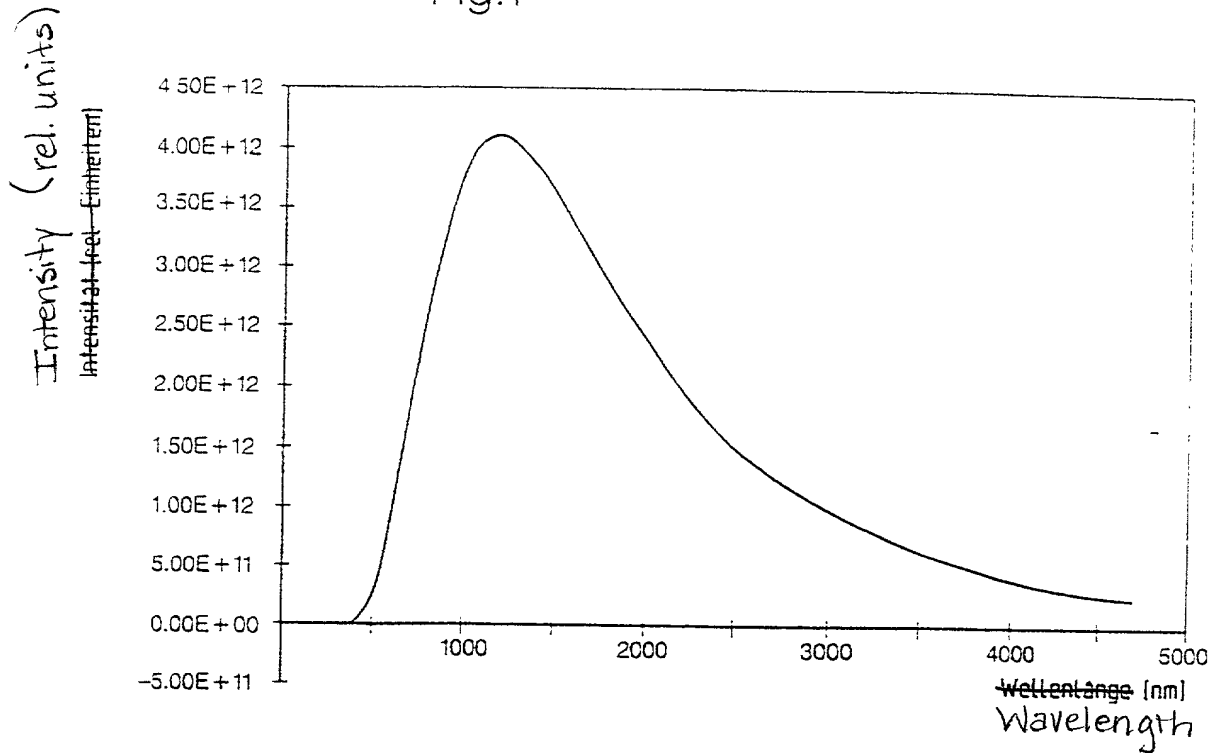
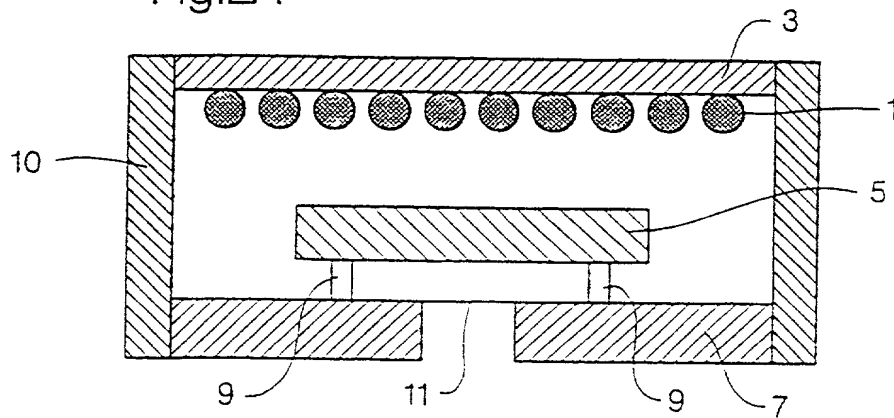
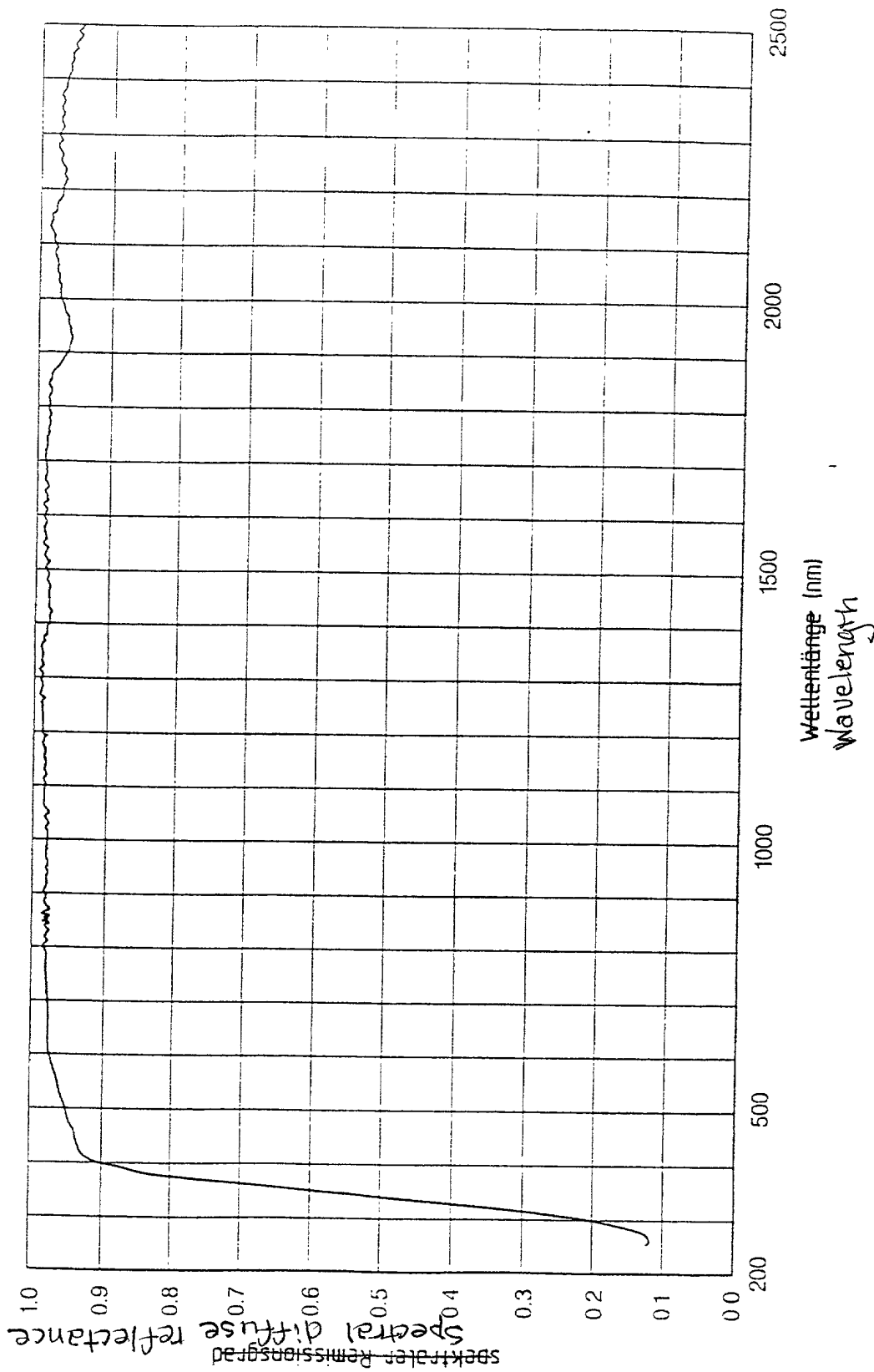


Fig.2A



2/6

Fig.2B



3/6

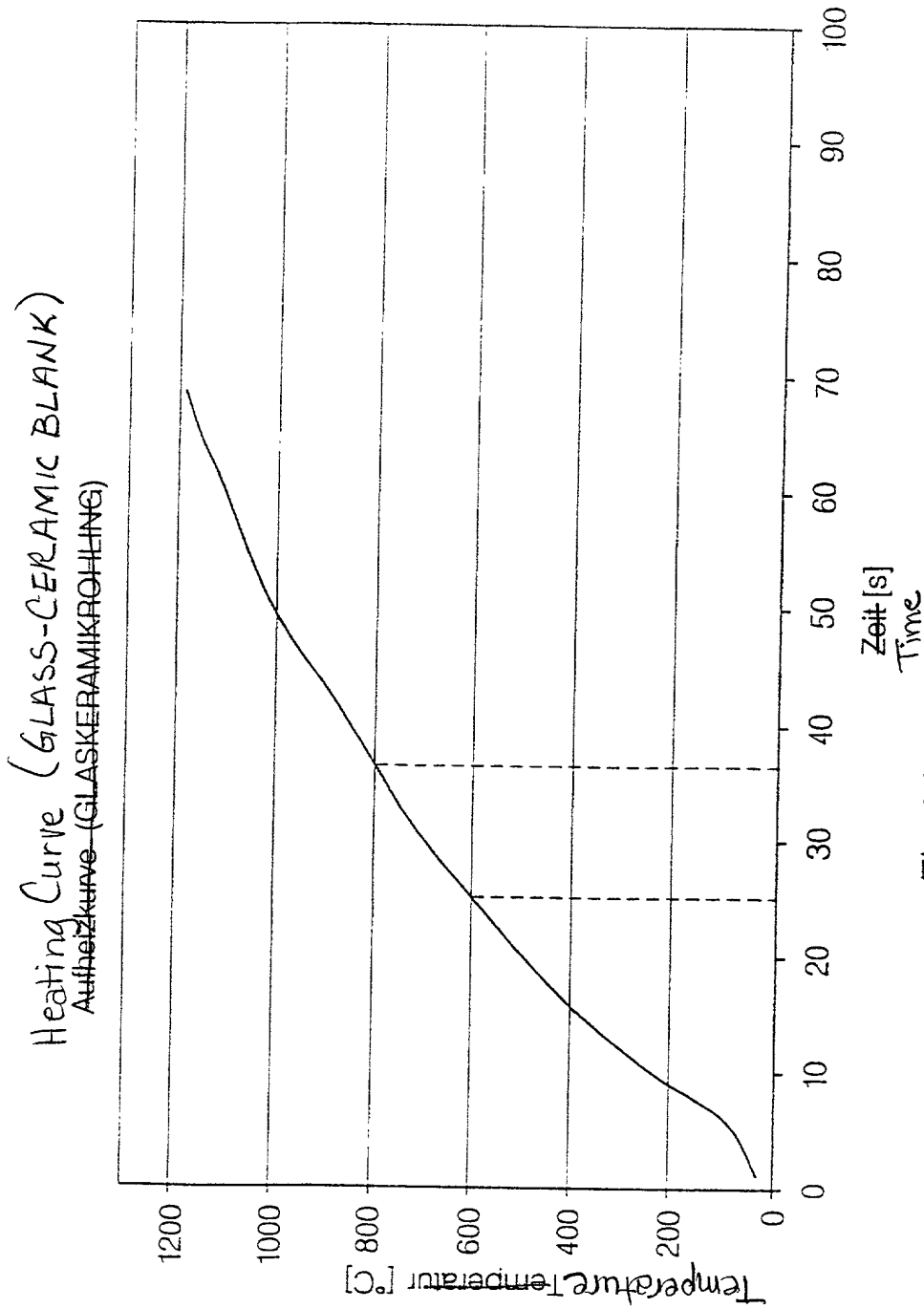


Fig.3A

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Heating Curve (GLASS-CERAMIC BLANK)
Aufheizkurve (GLASKERAMIKROHRLING)

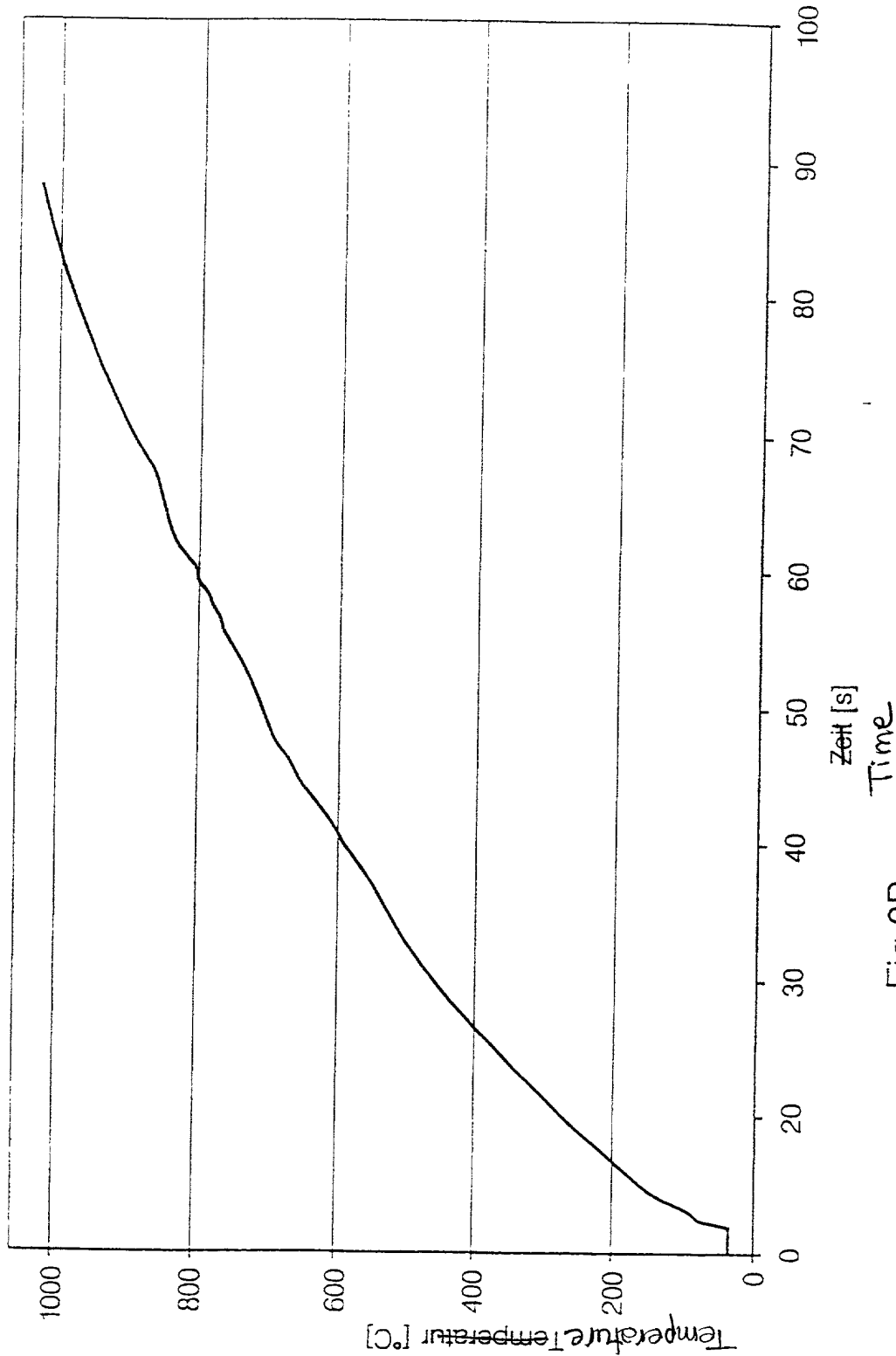


Fig.3B

5/6

Fig.4A

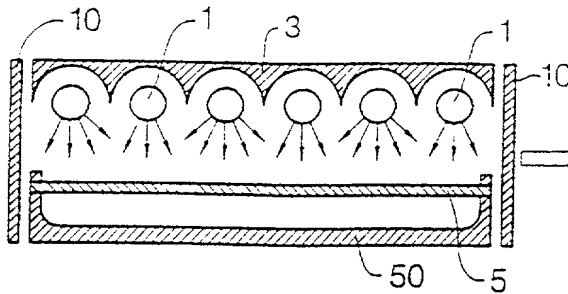


Fig.4B

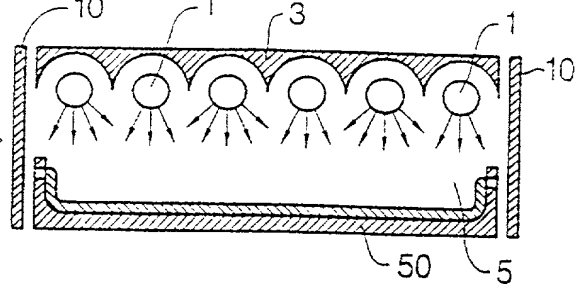


Fig.5A

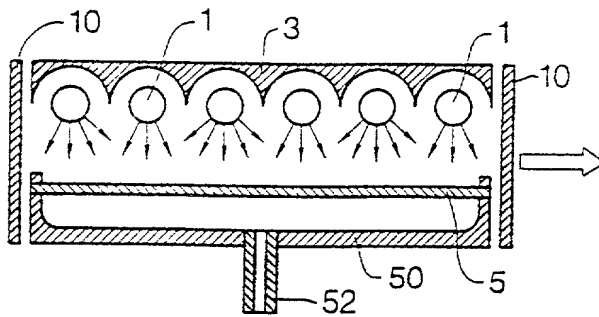


Fig.5B

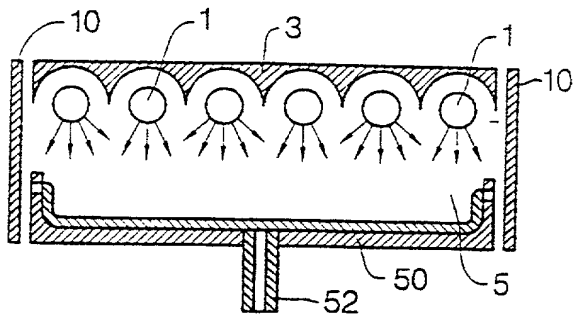


Fig.6A

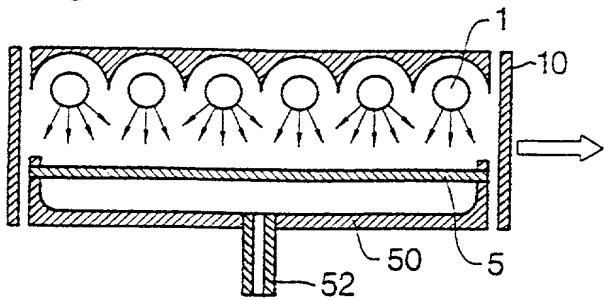


Fig.6B

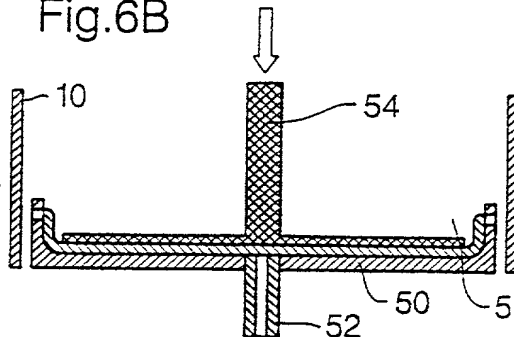


Fig.7A

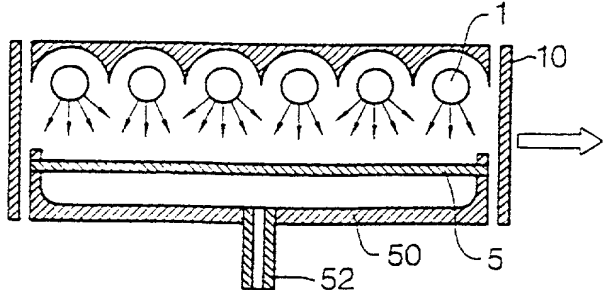
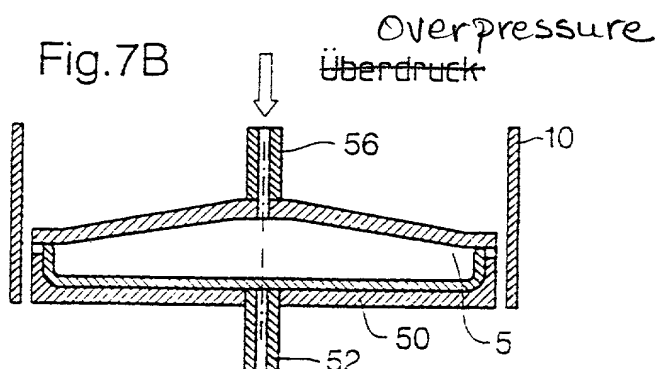


Fig.7B



6/6

Fig.8

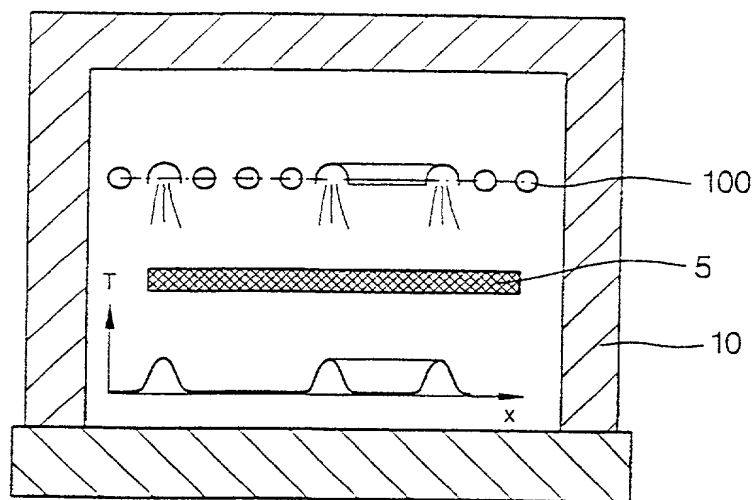
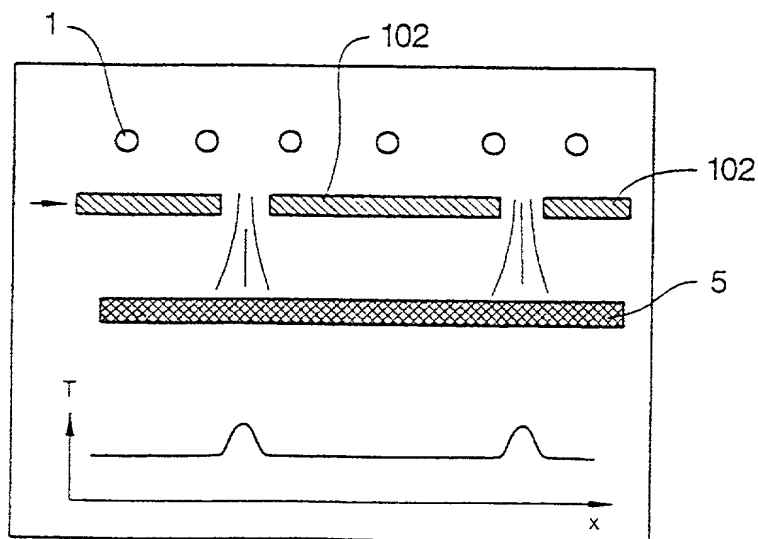


Fig.9



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PTO/SB/103 (8-96)

Approved for use through 9/30/98. OMB 0651-0032

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I believe I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural names are listed below) of the subject matter which is claimed and for which a patent is sought on the invention entitled:

METHOD OF FORMING GLASS-CERAMIC PARTS AND/OR GLASS PARTS

the specification of which is attached hereto unless the following box is checked:

☒ was filed on March 22, 2000 as United States Application Number or PCT International Application Number PCT/EP00/02505 and was amended on _____ (if applicable).

I hereby state that I have reviewed and understand the contents of the above identified specification, including the claims, as amended by any amendment referred to above.

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[Page 1 of 3]

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199 38 811.3	Germany
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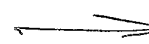
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Unterschrift des zweiten Erfinders	Datum	Second Inventor's signature	Date
		<i>Hauke Esemann</i>	11/06/01
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(Im Falle dritter und weiterer Miterfinder Miterfinder sind die entsprechenden Informationen und Unterschriften hinzuzufügen.)

(Supply similar information and signature for third and subsequent joint inventors.)



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